Synthesis and Characterization of Strontium Titanate Nanoparticles as Potential High Temperature Oxygen Sensor Material

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We present a simple and highly reproductive method for the preparation of thin films consisting of strontium titanate nanoparticles. The films are produced by spin coating of a sol on silicon targets and subsequent annealing under ambient conditions. Analysis by atomic force microscopy shows particles with typical sizes between 10 nm and 50 nm. X-ray photoelectron spectroscopy displays a stoichiometry of the films as anticipated from preliminary experiments with strontium titanate single crystals. Metastable-induced electron spectroscopy and ultraviolet photoelectron spectroscopy are used as tools to give evidence to the similar electronic properties of nanoparticle film and single crystal. These results support the prospect for an application of the nanoparticle films as high temperature oxygen sensor with superior properties.

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1. INTRODUCTION

Donor doped SrTiO$_3$ (STO) is well known for its capability as resistive high temperature oxygen sensor [1–4]. STO is stable without recrystallization over a wide temperature range between 104 K and about 2300 K [5]. Furthermore, STO accepts very high donor dopant concentrations up to 30% without any phase transition thus allowing to vary the sensor capacity over a wide range [6, 7]. Especially very porous donor doped STO was found to be of interest, because it provides quick response times in contrast to STO crystals. 0.5 at.-% Nb-doped STO layers, for example, show response times around 30–40 ms at 1130 K [1]. These response times can be improved even further if the particle size is decreased. Meyer and Waser found, that STO crystalline material with grain sizes of about 1 μm provides response times of about 10 ms [2].

Response times in the range of ms are necessary for most applications, for example, for oxygen sensors in car exhaust management. Therefore, the donor doped STO nanocrystalline particles may be of relevance in future high temperature oxygen sensor applications.

Sol-gel is a powerful method for preparation of nanoscaled oxide powders and nanoscale thin films for a variety of applications. It enables processing of refractory oxide layers at temperatures as low as 370 K in some special cases [8]. Materials with different compositions can be easily obtained in the form of glasses, fibers, ceramic powders, and thin films [9]. Multilayers are also easily made by means of sol-gel methods [10].

In this study we report a sol-gel route for the production of undoped and donor doped STO nanostructured thin films for sensor applications. We characterized these films by microscopic and electron spectroscopic methods.

2. EXPERIMENTAL

2.1. STO-sol and STO coatings preparations

STO sols were synthesized by means of a sol-gel method starting from alkoxides of the corresponding metals. The reagent grade chemicals used were Sr(C$_2$H$_3$O$_2$)$_2$ (99.995% Sr—Sigma-Aldrich) and Ti(OC$_4$H$_9$)$_4$ (97% Ti—Sigma-Aldrich). First, Sr-acetate was dissolved in concentrated
acetic acid under addition of small amounts of acetyl acetone which acts as a complexing agent. The dissolution of Sr-acetate was performed on a magnetic stirrer under continuous heating. After a clear solution of Sr-acetate was obtained Ti-butoxide was added dropwise to the solution.

For the preparation of Nb-doped STO, sol Nb(C₂H₃O₂)₅ (99.9% Nb—Strem Chemicals) was weighed and added with a syringe to an aliquot of the aforementioned undoped STO sol. In order to achieve the optimal viscosity of the final sol to be spin coated, we continued heating of the Nb-doped STO sol under stirring. The final sol was clear and stable on storage.

STO layers were applied on Si-wafers by means of spin coating upon addition of 20, 50, and 60 μl of the STO sol, followed by spinning at 12000 s⁻¹ for 15 seconds. After deposition, the layers were left in ambient air for 1 hour and then thermally treated in air according to the following program: 2 K/min up to 570 K with a dwell of 30 minutes, and further with 3 K/min up to 1000 K with a 1-hour dwell. The samples were cooled down to room temperature at a cooling rate of 3 K/min.

### 2.2. STO particle characterization

The spectroscopic measurements were carried out using an ultrahigh vacuum (UHV) apparatus with a base pressure of 5 × 10⁻⁹ Pa, which has been described in detail previously [11].

Electron spectroscopy is performed with a hemispherical analyzer (VSW HA100) in combination with a source for metastable helium atoms (He⁺) and ultraviolet photons (HeI line) for metastable induced electron spectroscopy (MIES) and ultraviolet photoelectron spectroscopy (UPS) as well as with a commercial non-monochromatic X-ray source (Specs RQ20/38C) for X-ray photoelectron spectroscopy (XPS).

During XPS, X-ray photons hit the surface under an angle of 80° to the surface normal, illuminating a spot with a diameter of a few millimeters. For the measurements shown here we used the Mg Kα and Al Kα lines with photon energies of 1253.7 eV and 1486.7 eV. Emitted electrons were analyzed by the hemispherical analyzer under 10° to the surface normal with a resolution of 1.1 eV. All XPS spectra are displayed as a function of the electron binding energy with respect to the Fermi level. Therefore, an apparent shift of all Auger lines by 233.0 eV occurs when switching between excitation sources.

For quantitative XPS analysis, the photoelectron peak area is calculated by mathematical fitting with Gauss-type profiles using OriginPro 7 G including the PFM fitting module. Photoelectric cross sections as calculated by Scofield [12] and inelastic mean free paths from the NIST database [13] are taken into account when calculating stoichiometry. Furthermore, the transmission function of our hemispherical analyzer is included into the calculation.

MIES and UPS are performed applying a cold cathode gas discharge via a two-stage pumping system. Here, metastable He⁺ atoms and Hel photons are produced. The ratio between He⁺2S and He⁺21S amounts to 7 : 1 [14] at least. Therefore, no contribution of the He⁺21S-surface interaction can be detected. A time-of-flight technique is used to separate electrons emitted by He⁺ (MIES) and HeI (UPS) interaction with the surface. The mixed He⁺/HeI beam strikes the surface under an angle of 45° and illuminates an area of about 2 mm diameter on the sample surface. MIES and UPS spectra are simultaneously recorded by the hemispherical analyzer with a resolution of 220 meV under normal emission within 130 second.

Metastable He⁺ atoms may interact with the sample via different mechanisms depending on surface electronic structure and work function [15, 16]. In this work, we will only discuss the relevant processes.

During Auger deexcitation (AD), an electron from the sample surface fills the 1s orbital of the impinging He⁺. Simultaneously, the He 2s electron is emitted carrying the excess energy. The resulting spectra directly display the surface density of states (SDOS). The excitation potential of the He⁺ amounts to 19.8 eV [15–18]. Because the He⁺ atoms interact with the surface in distances typically between 0.3 and 0.5 nm in front of it, MIES is extremely surface sensitive and displays the SDOS of the uppermost layer of the sample only. To distinguish surface from bulk effects, AD-MIES and UPS can be compared directly.

For STO, a different interaction takes place: the 2s electron of the impinging He⁺ is resonantly transferred into the surface of the sample and localizes at near surface Ti 3d states. Subsequently, a Ti 3d electron fills the hole in He⁺ 1s in an interatomic Auger neutralization (AN) process, followed by the emission of an O(2p) surface electron carrying the excess energy. The energy of the resulting MIES peak is shifted by 1.2 eV toward higher binding energies compared to AD due to a diminished local ionization potential. A detailed discussion of this process is given in [19].

Oxygen incorporation into STO most strongly depends on the dissociation probability in the vicinity of the surfaces. This probability depends on the very outermost surface wave functions which are most sensitively probed by MIES.

All MIES and UPS spectra are displayed as a function of the electron binding energy with respect to the Fermi level. The surface work function can be determined from the left onset of the MIES or the UPS spectra with an accuracy of 0.1 eV.

The silicon samples bearing the STO nanoparticles are mounted in a molybdenum sample holder and transferred into the UHV via a transfer system. Afterwards, the sample is cleaned from surface contamination by heating to about 850 K before measuring.

Atomic force microscopy (AFM) measurements are performed with a digital instruments dimension 3100 AFM in tapping mode using a silicon cantilever. The AFM is operated under ambient conditions. AFM images are analyzed concerning particle size distribution and surface roughness with SPIP 3.2 from image metrology.

Auger depth profiles were used to measure the thickness of the STO layers on the silicon by sputtering with argon under control of a PHI Auger microprobe system. These
measurements were carried out in a separate vacuum chamber.

3. RESULTS

Figure 1 shows the AFM images of a STO undoped (Figure 1(a)) and Nb-doped (Figure 1(b)) nanoparticle film, which was produced via the sol-gel route described in Section 2. After deposition the samples were transferred to the microscope immediately. We evaluate an average size of 25 nm with a full width at half maximum (FWHM) of 20 nm for the undoped particles and an average size of 50 nm with a FWHM of 30 nm for the donor doped particles. The films are thinner than 100 nm in both cases, which was evaluated by Auger depth profile analysis. The particle sizes and their distributions can be reproduced with high accuracy applying the synthesis parameters described in Section 2. The surfaces possess roughnesses of about 3.8 nm for the undoped and 6.3 nm for the doped films (root mean square corresponding to ISO 4287/1). Heating to temperatures substantially higher than described in Section 2.1 does not change neither the size nor the distribution of the nanoparticles.

Figure 2 shows the XPS spectra of the undoped (Figure 2(a)) and Nb-doped (Figure 2(b)) STO nanoparticle films shown in Figure 1. The samples were immediately inserted into the UHV after the microscopy. The peak areas are analyzed as described in Section 2 and are compared with the corresponding ones for stoichiometric STO. For the undoped particles we find a composition near to STO but with a Sr concentration about 5% lower than the Ti concentration. Comparable values are found for the doped particles with a Nb concentration of about 1 at.-%. This corresponds well to the value expected from preparation.

Besides the peaks corresponding to STO we observe Mo, C, and Na signals. Mo is due to the sample holder and is not
found on the sample surface. C is typically due to a surface contamination with carbon containing species like CO₂ or CO₃⁻. The Na contamination is mostly due to NaCl residues from the deposition process.

It is well known from literature that donor doped STO crystals heated under ambient conditions loose Sr [20, 21]. We assume that the annealing during the synthesis process induces similar processes on the nanoparticle surfaces, thus reducing the Sr concentration.

Figure 3 shows MIES (Figure 3(a)) and UPS spectra (Figure 3(b)) of the undoped nanoparticle film discussed above compared with corresponding spectra for SrTiO₃(100) single crystals [19, 22, 23]. Nb-doped nanoparticles show similar spectra which are therefore not shown here. The spectra are displayed as a function of the binding energy \( E_B \) with the Fermi level at \( E_B = 0 \) eV. The contributions beyond \( E_B \approx 10 \) eV are induced by secondary electrons and will not be discussed here. The MIES spectra show one peak at \( E_B = 6.5 \) eV being induced by the localized AN process described in Section 2 [19]. This peak is well known and corresponds to the ionization of non-hybridized O(2p) of the SrTiO₃(100) surface, which is terminated by a TiO₂ layer [24]. The valence band maximum (VBM) of SrTiO₃(100) single crystals is found around \( E_B = 3.2 \) eV while the VBM on the STO particle film reaches to \( E_B \approx 1.9 \) eV.

UPS shows a double peak structure at \( E_B = 7.0 \) eV and \( E_B = 4.9 \) eV. The peak at higher binding energy corresponds to the ionization of O(2p) orbitals being hybridized with Ti 3d, while the peak at lower binding energy is due to non-hybridized O(2p). The VBM is found around \( E_B \approx 3.2 \) eV for the single crystal and the film.

4. DISCUSSION

Applying the simple synthesis procedure described in Section 2, films containing nanoscale particles are produced easily. These particles consist of Sr, Ti, and O with near STO stoichiometry. The reduced Sr concentration is most probably due to the applied heating procedure described in Section 2. It is well known that an Sr loss occurs during heating STO single crystals in oxygen containing atmospheres. UPS and MIES show a quite good similarity between the particle film and well-defined SrTiO₃(100) surfaces. The latter one is known to show good high temperature oxygen sensor capabilities. The (110) and (111) surfaces are known to show the same electronic structures.

The similarity between the UPS spectra proves that the surface density of states of the nanoparticles is very similar to the one for STO single crystals. It is known that the electronic and geometric structure of STO does not change even for large amount of Sr vacancies inside the crystal [6, 7].

The interaction of the impinging He⁺ atoms approaching the surface with thermal velocity probes only the very outermost surface wave functions. These wave functions are also responsible for the interaction of sensor surfaces with impinging oxygen or ambient atmospheres molecules. In this sense MIES is a very reasonable and powerful tool to investigate the heterogenous reactivity of the sensor surface. The observed similarity between the MIES spectra for single crystal and the film is of great relevance for future sensor applications. It suggests that the nanocrystalline film can be expected to behave similarly to STO single crystals. Furthermore, in MIES contributions within the STO band gap are
observed. These are likely due to surface defects, which will enhance the surface reactivity further.

It was shown previously that typical oxygen diffusion lengths in STO amount to several 10 nm in a diffusion time of 10 ms [25]. The oxygen diffusion on the nanoparticles surfaces may be expected to be much faster than inside the crystals. For ZrO2 it was found that the surface diffusion is about 10^4 times faster than the diffusion into the bulk [26]. This means that nanoparticles with a diameter of several 10 nm can be expected to provide a very high signal, because all particles contribute to the oxygen sensor signal with their complete volume.

5. SUMMARY

Undoped and 1 at.% Nb-doped nanoparticle containing films with near STO stoichiometry were produced applying a simple sol-gel procedure. The undoped particles show a mean diameter of 25 nm with a FWHM of 20 nm while the doped particles show a mean diameter of 50 nm with a FWHM of 30 nm. The films are electronically very similar to STO single crystals. Their surface provides a reactivity which is expected to be even higher than the ones for single crystal surfaces. On the one hand, the particle size of several 10 nm is sufficiently high to provide stable electronic conditions of the particles. On the other hand, the size is low enough to allow complete oxygen diffusion into the particles within 10 ms. It can be expected that oxygen diffusion on the particles surface is very fast. Therefore, the produced nanocrystalline STO is a highly promising candidate for a very fast and very sensitive high temperature oxygen sensor.

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